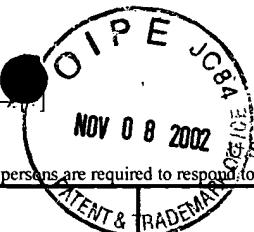


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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	09/295,607		
				Filing Date	4-22-1999		
				First Named Inventor	Shunpei YAMAZAKI et al.		
				Group Art Unit	2811		
				Examiner Name	Steven Loke		
Sheet	1	of	1	Attorney Docket Number	740756-1961		

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

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Examiner Initials*	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (if known)			
Luke	EP	0 456 199	A2	Kunio Masumo et al.	11/13/1991		.Full

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				First Named Inventor	Shunpei YAMAZAKI et al.
				Art Unit	2811
				Examiner Name	Steven Ho Yin Loke
				Attorney Docket Number	740756-1961

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Loke		JP 02-105115		04-17-1990	Saburo Oikawa et al.		AB
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Loke		Ito et al. "Thin Film Technology of VLSI" pp 87-88, published on September 30, 1986 by Maruzen Co., Ltd. (with English Abstract)			
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